IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of: Kuei-Wu Huang, et al.

Serial No.:

10/687,713

Group Art Unit: 1765

Filed:

October 17, 2003

Examiner: L. Vinh

For:

SURFACE TREATED LOW-K DIELECTRIC AS DIFFUSION BARRIER FOR COPPER METALLIZATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action of January 6, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.